

## Registered Patent Attorney - Technology and Intellectual Property Matters http://www.attycubed.com

Twin Oaks Office Plaza 477 Ninth Avenue, Suite 112 San Masso, California 94402-1854 Telephone: (650) 348-1444 Facsimile: (650) 348-8655 e-mail: rks@attycubed.com

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)		
PATON	)	Information Disclosure	STATEMENT(R. 56)
	)		
	)		
Serial No.: 09/680,286	)		
Filing Date: October 6, 2000	)	Date Mailed: October 15, 2002	
Attorney Docket No.: ENP-101	)	Examiner:	NOLAND, Thomas F
	)	Group Art Unit:	2856
Title: REMOTE MONITORING	)		
OF CRITICAL PARAMETER	RS)		
FOR CALIBRATION OF	)		
MANUFACTURING	)		
EQUIPMENT	)		
AND FACILITIES	)		
	)		

Commissioner of Patents and Trademarks Washington, D.C. 20231

## INFORMATION DISCLOSURE STATEMENT(R. 56)

Dear Sir:

IDS

Pursuant to 37 C.F.R. 1.97 the Applicant submits the following information disclosure statement and the accompanying documents.

The Applicant has not caused the comprehensive search to have been made concerning the invention disclosed and claimed in the application; this information simply presents those items known to the Applicant which the Applicant considers material to an examination of this application.

Title: REMOTE MONITORING OF CRITICAL PARAMETERS FOR CALIBRATION OF MANUFACTURING EQUIPMENT AND FACILITIES

NUFACTURING EQUIPMENT AND FACILITIES Serial No.: 09/680,286

Attorney Docket No.: ENP-101

CERTIFICATION RE FOREIGN APPLICATION CITATION

Applicants hereby certify that each item of information contained in this information disclosure statement cited to Applicant(s) in a communication from a foreign search report in a counterpart foreign application was not cited to Applicant(s) more than three months prior to the filing of this statement.

The accompanying documents include:

- 1. U.S. Patent No. 5660472 issued August 26, 1997 to Peuse et al.;
- 2. U.S. Patent No. 5967661 issued October 19, 1999 to Renken et al.;
- 3. U.S. Patent No. 5969639 issued October 19, 1999 to Lauf et al.; and
- 4. U.S. Publication No. 2001/0021621 A1 published September 13, 2001.

Respectfully submitted,

Dated: October 15, 2002\_

RAYK. SHAHANI ATTORNEY AT LAW

By: Ray K Shan

Attorney for Applicant(s)

Ray K. Shahani, Esq.

Attorney at Law

Twin Oaks Office Plaza

477 Ninth Avenue, Suite 112

San Mateo, California 94402-1854

Telephone: (650) 348-1444 Facsimile: (650) 348-8655

E-mail: rks@attycubed.com

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents attached hereto are being deposited in a postage prevaid, sealed envelope with the United States Postal Service using First Class Mail service under 37 CFR 1.08 on the date indicated and is addressed to

"Commissioner of Patents and Trademarks, Washington, D.C. 20231". Signed:

Mailed: October 15, 2002

Title: REMOTE MONITORING OF CRITICAL PARAMETERS FOR CALIBRATION OF MANUFACTURING EQUIPMENT AND FACILITIES

Serial No.: 09/680,286 Attorney Docket No.: ENP-101

Registration No.: 37,554

IDS